

| | Application No. | Applicant(s) |
|--|---|------------------------------------|
| Notice of Allowability | 10/083,261 | CHOI ET AL. |
| | Examiner | Art Unit |
| | George Y. Wang | 2871 |
| The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. | | |
| 1. This communication is responsive to <u>Applicant's Pre-Appeal Brief filed November 23, 2005</u> . | | |
| 2. The allowed claim(s) is/are <u>1,2,7-12,33 and 35-40</u> . | | |
| 3. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: | | |
| Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. | | |
| 4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. | | |
| 5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. | | |
| (a) 🔲 including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached | | |
| 1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date | | |
| (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date | | |
| Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the | 84(c)) should be written on the drawing header according to 37 CFR 1.121(c | ngs in the front (not the back) of |
| 6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. | | |
| Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material | 6. ☐ Interview Summary Paper No./Mail Date 8), 7. ☒ Examiner's Amendm 8. ☒ Examiner's Stateme | ė . |
| • | 9. | |

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EXAMINER'S AMENDMENT

Examiner's Amendment

- 1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- 2. Authorization for this examiner's amendment was given in a telephone interview with David Heath on January 18, 2006.
- 3. The application has been amended as follows:
 - Claims 41-56 cancelled.

Reasons for Allowance

4. The following is an examiner's statement of reasons for allowance: As the claims were read and interpreted in light of the specification, the prior art of record fails to specifically disclose a thin film transistor (TFT) array comprising, in particular, a second insulating layer formed on the TFT having a dielectric about 4.0 or less and formed with an a-Si:C:O or a-Si:O:F layer and where the layer has a first contact hole exposing a predetermined electrode of the TFT. Although Gu (U.S. Patent No. 6,376,270) teaches a similar structure, the reference fails to specifically disclose a second insulating layer

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formed on the TFT with an a-Si:C:O or a-Si:O:F layer. While Murakami (U.S. Patent No. 5,053,844) does teach an insulating layer formed with an a-Si:C:O or a-Si:O:F layer, it does not teach such a layer on a TFT but rather a photosensor with a marked different intended purpose and advantages than that of Applicant's second insulating layer, thereby not rendering the combination as obvious (see Applicant's Arguments present in Pre-Appeal Brief Request filed November 23, 2005). Murakami's a-Si:O:F insulating layer is used to reduce band-gap while Applicant's layer is used to reduce or minimize paracistic capacitance between the first pixel electrode and the second signal line. Since the elements are of different technical fields and have no common intended purpose or advantages, no exists no obviousness motivation. Thus, allowance is proper.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to George Y. Wang whose telephone number is 571-272-2304. The examiner can normally be reached on M-F, 8 am - 4:30 pm.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert H. Kim can be reached on 571-272-2293. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

George Y. Wang Examiner Art Unit 2871

January 23, 2006

ANDREW SCHECHTER PRIMARY EXAMINER